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10784979 - GAI: 2166

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10784979	
	Filing Date		2004-02-25	
	First Named Inventor	YACH, David P.		
	Art Unit	2166		
	Examiner Name	LIN, Shew Fen		
	Attorney Docket Number	P1645US00		

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